



ELECTRONIC INFORMATION DISCLOSURE STATEMENT

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Title of Invention	SOURCE PIN LOADING METHODS AND APPARATUS FOR POSITRON EMISSION TOMOGRAPHY																																																																																																																																						
<p>Application Number: 10/065584</p> <p>Confirmation Number: 9764</p> <p>First Named Applicant: Hani Noshi</p> <p>Attorney Docket Number: 125739</p> <p>Art Unit: 2881</p> <p>Examiner: Christopher M. Kalivoda</p> <p>Search string: (4235454 or 4501011 or 4791934 or 5594638 or 5711297 or 5724968 or 5821541 or 5834780 or 5868669 or 5910107 or 6022315 or 6113540 or 6160263 or 6201247 or 6206829 or 6434216).pn.</p>																																																																																																																																							
<h3>US Patent Documents</h3> <p>Note: Applicant is not required to submit a paper copy of cited US Patent Documents</p> <table border="1"><thead><tr><th>init</th><th>Cite.No.</th><th>Patent No.</th><th>Date</th><th>Patentee</th><th>Kind</th><th>Class</th><th>Subclass</th></tr></thead><tbody><tr><td>CMK</td><td>1</td><td>4235454</td><td>1980-11-25</td><td>Gray et al.</td><td></td><td></td><td></td></tr><tr><td>CMK</td><td>2</td><td>4501011</td><td>1985-02-19</td><td>Hauck et al.</td><td></td><td></td><td></td></tr><tr><td>CMK</td><td>3</td><td>4791934</td><td>1988-12-20</td><td>Brunnett</td><td></td><td></td><td></td></tr><tr><td>CMK</td><td>4</td><td>5594638</td><td>1997-01-14</td><td>Iliff</td><td></td><td></td><td></td></tr><tr><td>CMK</td><td>5</td><td>5711297</td><td>1998-01-27</td><td>Iliff</td><td></td><td></td><td></td></tr><tr><td>CMK</td><td>6</td><td>5724968</td><td>1998-03-10</td><td>Iliff</td><td></td><td></td><td></td></tr><tr><td>CMK</td><td>7</td><td>5821541</td><td>1998-10-13</td><td>Tumer</td><td></td><td></td><td></td></tr><tr><td>CMK</td><td>8</td><td>5834780</td><td>1998-11-10</td><td>Morgan et al.</td><td></td><td></td><td></td></tr><tr><td>CMK</td><td>9</td><td>5868669</td><td>1999-02-09</td><td>Iliff</td><td></td><td></td><td></td></tr><tr><td>CMK</td><td>10</td><td>5910107</td><td>1999-06-08</td><td>Iliff</td><td></td><td></td><td></td></tr><tr><td>CMK</td><td>11</td><td>6022315</td><td>2000-02-08</td><td>Iliff</td><td></td><td></td><td></td></tr><tr><td>CMK</td><td>12</td><td>6113540</td><td>2000-09-05</td><td>Iliff</td><td></td><td></td><td></td></tr><tr><td>CMK</td><td>13</td><td>6160263</td><td>2000-12-12</td><td>Smith et al.</td><td></td><td></td><td></td></tr><tr><td>CMK</td><td>14</td><td>6201247</td><td>2001-03-13</td><td>Lutheran et al.</td><td></td><td></td><td></td></tr><tr><td>CMK</td><td>15</td><td>6206829</td><td>2001-03-27</td><td>Iliff</td><td></td><td></td><td></td></tr></tbody></table>								init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass	CMK	1	4235454	1980-11-25	Gray et al.				CMK	2	4501011	1985-02-19	Hauck et al.				CMK	3	4791934	1988-12-20	Brunnett				CMK	4	5594638	1997-01-14	Iliff				CMK	5	5711297	1998-01-27	Iliff				CMK	6	5724968	1998-03-10	Iliff				CMK	7	5821541	1998-10-13	Tumer				CMK	8	5834780	1998-11-10	Morgan et al.				CMK	9	5868669	1999-02-09	Iliff				CMK	10	5910107	1999-06-08	Iliff				CMK	11	6022315	2000-02-08	Iliff				CMK	12	6113540	2000-09-05	Iliff				CMK	13	6160263	2000-12-12	Smith et al.				CMK	14	6201247	2001-03-13	Lutheran et al.				CMK	15	6206829	2001-03-27	Iliff			
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CMK	16	6434216	2002-08-13	Maki et al.
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Signature

Examiner Name	Date
Chris Kahwood	14 Oct 03